## Notice of References Cited Application/Control No. O9/779,222 Examiner Djenane M Bayard Applicant(s)/Patent Under Reexamination COVELLI ET AL. Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-2005/0034029	02-2005	Ramberg et al.	714/043
	В	US-			
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	D	US-			
	E	US-			
	F	US-			
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	К	US-			
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## **NON-PATENT DOCUMENTS**

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